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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: 005329 USA Y1/MASK/RT/OR

Shirley HEMAR, et al.

Appln. No.: 09/876,955

Group Art Unit: 2625

Confirmation No.: 4359

Examiner: John B. STREGE

Filed: June 7, 2001

For: ALTERNATING PHASE-SHIFT MASK INSPECTION METHOD AND APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 10, 2005, please amend the above-identified application as follows on the accompanying pages.

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